

**Notice of References Cited**

Application/Control No.

10/699,991

Applicant(s)/Patent Under  
Reexamination  
LERNER ET AL.

Examiner

Jennifer Kim

Art Unit

1617

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,150,113	04-1979	Hoogendoorn et al.	424/50
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP9249562	09-1997	Japan	Obata Nobuko et al.	-----
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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